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Attorney's Docket No.: 42P17764

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:

Alejandro Hurtado

Application No.: 10/769,534

Filed: January 30, 2004

For: **MOUNTING AND DICING PROCESS
FOR WAFERS**

Examiner: **Ha, Nathan W.**

Art Unit: 2814

Confirmation No.: 8641

MAIL STOP RCE
Commissioner for Patents
P.O. Box 1450
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PRELIMINARY AMENDMENT

Sir:

In connection with the filing a Request for Continued Examination under 37 CFR §1.114, Applicants respectfully request consideration of the following amendment.